

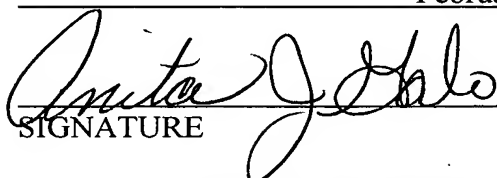


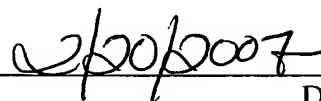
IFW

**PATENT**

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE U.S. POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450 ON:

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Aaron J. Fleischman et al.  
Serial No. : 10/626,221  
Filing Date : July 24, 2003  
For : MEMS-BASED INTEGRATED MAGNETIC  
PARTICLE IDENTIFICATION SYSTEM  
Art Unit : 1641  
Examiner: : Leon Yun Bon Lum  
Attorney Docket No. : CCF-5760-1  
Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

In response to the Examiner's communication of October 19, 2006, please amend and reconsider the above-identified application, as follows:

**Amendment to the Claims** are reflected in the listing of claims which begin on page 2 of this paper.

**Remarks** begin on page 10 of this paper.